## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	Examiner: Christopher M Raabe
TAKESHI ICHIKAWA ET AL.	
Application No.: 10/516,545	: Art Unit: 2879
Filed: December 2, 2004	: Conf. No.: 2864
For: ELECTRON-EMITTING DEVICE AND MANUFACTURING METHOD THEREOF	) : . February 12, 2010

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## AMENDMENT

Sir:

In response to the Office Action of November 12, 2009, please amend the above-identified application as follows.